4)

Docket No. 214814US0

IN RE APPLICATION OF: Tomichi MEYAKAWA

SERIAL NO: 09/975,262

FILED:

October 12, 2001

FOR:

METHOD FOR PRODUCING A SILICON NITRIDE FILTER

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS		RATE		CALCULATIONS
TOTAL	13	MINUS	20	0	х	\$18	=	\$0.00
INDEPENDENT	3	MINUS	3	0	х	\$86	=	\$0.00
☐ MULTIPLE DEPENDENT CLAIMS + \$290 =						\$0.00		
TOTAL OF ABOVE CALCULATIONS						NS	\$0.00	
☐ Reduction by 50% for filing by Small Entity							\$0.00	
		☐ Recordation of Assignment + \$40 =					=	\$0.00
TOTAL							AL	\$0.00

	A	check	in the	amount	of	\$0.00	is	attached
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- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Norman F. Oblon

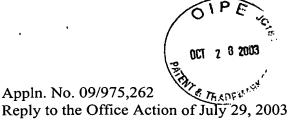
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214814US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Naomichi MIYAKAWA : GROUP ART UNIT: 1731

SERIAL NO.: 09/975,262

FILED: OCTOBER 12, 2001 : EXAMINER: FIORILLA, C.

FOR: METHOD FOR PRODUCING A

SILICON NITRIDE FILTER

AMENDMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Official Action of July 29, 2003, please amend the above-identified application as follows.

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims begin on page 3 of this paper.

Remarks/comments begin on page 7 of this paper.